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PATENT
Customer No. 22,852
Attorney Docket No. 8071.0007-00

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
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Takeshi MITSUISHI et al.) Group Art Unit: 2872
)
Application No.: 09/986,907) Examiner: Joshua Pritchett
)
Filed: November 13, 2001)
)
For: COMPOSITION FOR VAPOR) Confirmation No.: 6647
DEPOSITION, METHOD FOR)
FORMING AN ANTIREFLECTION)
FILM, AND OPTICAL ELEMENT)

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(d)

Pursuant to 37 C.F.R. §§ 1.56 and 1.97(d), applicants bring to the attention of the Examiner the documents listed on the attached PTO 1449. This Information Disclosure Statement is being filed after a Final Action but before payment of the issue fee and is accompanied by a fee of \$180.00 as specified under § 1.17(p) and a certification as specified under § 1.97(e). Applicants respectfully request that the Examiner consider the listed documents and indicate that they were considered by making appropriate notations on the attached form.

Each document listed in this Information Disclosure Statement was first cited in a communication from the European Patent Office in a counterpart foreign application,

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and this Information Disclosure Statement is being filed within three months of the mailing date of that communication.

Copies of the listed documents, including any copending patent applications, are attached.

In lieu of a statement of relevance or translation of the non-English documents, an English language version of a search report from the European Patent Office in a corresponding application citing these documents and setting forth the relevance thereof is enclosed.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claims in the application and applicants determine that the cited documents do not constitute "prior art" under United States law, applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of such documents.

Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

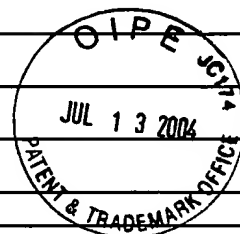
FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: July 13, 2004

By: Charles E. Van Horn
Charles E. Van Horn
Reg. No. 40,266

INFORMATION DISCLOSURE CITATION

Atty. Docket No.	8071.0007-00	Appln. No.	09/986,907
Applicant	Takeshi MITSUSHI et al.		
Filing Date	November 13, 2001	Group:	2872



U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Issue Date	Name	Class	Sub Class	Filing Date If Appropriate
	5,372,874	12/13/94	Dickey et al.			

FOREIGN PATENT DOCUMENTS

Document Number	Publication Date	Country	Class	Sub Class	Translation Yes or No
0 390 218	10/03/90	Europe			No (abstract)
59-148002	08/24/84	Japan			No (abstract)
59-154401	09/03/84	Japan			No (abstract)

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Guo, Xin et al., "Effect of Niobia on the Defect Structure of Yttria-stabilized Zirconia," Journal of the European Ceramic Society 18, No. 3 (1998), pages 237-240
European Search Report for Counterpart Foreign Application No. EP 1 205 774 A3 dated April 14, 2004

Examiner	Date Considered
*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	
Form PTO 1449	Patent and Trademark Office - U.S. Department of Commerce